Section I (Listing of the Claims)

A listing of the pending claims 1-20 of the application is set out below.

- (Previously presented) A method comprising: heating a polytetrafluoroethylene
 material to an elevated temperature; and maintaining said heating for a time sufficient
 to substantially reduce a particle count character of the polytetrafluoroethylene
 material.
- (Original) The method of claim 1 further comprising applying a melting temperature to a portion of the polytetrafluoroethylene material for welding thereof prior to said heating.
- 3. (Previously presented) The method of claim 2 wherein the melting temperature is within about 15°C of a melting point of the polytetrafluoroethylene material.
- 4. (Original) The method of claim 2 wherein said applying forms a heat affected zone of the portion, said heating and said maintaining to affect the heat affected zone.
- 5. (Previously presented) The method of claim 1 wherein the elevated temperature is above a glass transition temperature of the polytetrafluoroethylene material.
- 6. (Original) The method of claim 1 wherein the elevated temperature is between about 130°C and about 260°C.
- 7. (Original) The method of claim 1 wherein the time is between about 20 hours and about 100 hours.
- 8. (Previously presented) The method of claim 1 wherein said maintaining occurs in a periodic manner comprising:

cooling the polytetrafluoroethylene material; and reheating the polytetrafluoroethylene material.

- 9. (Previously presented) The method of claim 1 wherein said maintaining occurs in a periodic manner comprising:
 - cooling the polytetrafluoroethylene material; and reheating the polytetrafluoroethylene material.
- 10. (Previously presented) A method comprising heating a polytetrafluoroethylene material to about 228°C for a sufficient time to substantially reduce a particle count character thereof.
- 11. (Original) The method of claim 10 wherein said heating is for about 100 hours.
- 12. (Original) A polytetrafluoroethylene material having a particle count character reduced by application of an elevated temperature thereto.
- 13. (Original) The polytetrafluoroethylene material of claim 12 wherein the elevated temperature is between about 130° and about 260°C.
- 14. (Previously presented) The polytetrafluoroethylene material of claim 12 wherein the application of the elevated temperature is for between about 20 hours and about 100 hours.
- 15. (Original) The polytetrafluoroethylene material of claim 12 wherein the elevated temperature is about 228°C and the application is for about 100 hours.
- 16. (Previously presented) The polytetrafluoroethylene material of claim 12 in the form of a film for contacting a substance.
- 17. (Original) The polytetrafluoroethylene material of claim 16 wherein the substance is one of a liquid and a powder.

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18. (Previously presented) The polytetrafluoroethylene material of claim 17 wherein the film is incorporated in a package to contain the substance.

19. (Withdrawn) A method of determining a temperature and time at which heat processible polytetrafluoroethylene (PTFE) fluoropolymer films are heat-treatable to reduce particle count thereof, comprising:

providing a set of heat processible PTFE fluoropolymer films;

subjecting each film of said set of heat processible PTFE fluoropolymer films to a predetermined temperature for a predetermined time of heat processing, wherein temperature and time of heat processing are varied among films in said set, to provide a range of heat processing temperatures and a range of heat processing times for heat processed films in said set;

after said heat processing, determining particle counts for the heat processed films in said set;

performing regression analysis on the particle counts to determine temperature and heat processing time at which particle count is minimized, as said determined temperature and time.

20. (Withdrawn) A method of treating a polytetrafluoroethylene film to reduce particle count character thereof, comprising exposing the film to a temperature in a range of from about 150°C to about 250°C for a time greater than 20 hours, sufficient to reduce particle count of said film to below 10 particles/ml of particles having a diameter of 0.2 micron.